

**AUG 20 2005**

---

**FACSIMILE**  
**TRANSMISSION TO USPTO**

**DATE: August 20, 2005**

THIS MESSAGE IS INTENDED ONLY FOR THE USE OF THE INDIVIDUAL OR ENTITY TO WHICH IT IS ADDRESSED, AND MAY CONTAIN INFORMATION THAT IS PRIVILEGED, CONFIDENTIAL AND EXEMPT FROM DISCLOSURE UNDER APPLICABLE LAW. IF THE READER OF THIS MESSAGE IS NOT THE INTENDED RECIPIENT, OR THE EMPLOYEE OR AGENT RESPONSIBLE FOR DELIVERING THE MESSAGE TO THE INTENDED RECIPIENT, YOU ARE HEREBY NOTIFIED THAT ANY DISSEMINATION, DISTRIBUTION OR COPYING OF THIS COMMUNICATION IS STRICTLY PROHIBITED. IF YOU HAVE RECEIVED THIS COMMUNICATION IN ERROR, PLEASE NOTIFY THE SENDER IMMEDIATELY BY TELEPHONE AND RETURN THE ORIGINAL MESSAGE VIA THE U.S. POSTAL SERVICE. THANK YOU.

**Document(s) Attached: Amendment, Transmittal**  
**Total Pages: 6 (including this page)**

In re application of:	Joel P. DeSouza et al.
Serial Number:	10/604,146
Filing Date:	June 27, 2003
Attorney:	H. Daniel Schnurmann IBM Corporation Intellectual Property Law, Dept 18G Building 321, M/S 482 2070 Route 52 Hopewell Junction, NY 12533

**PLEASE DELIVER TO:**

**EXAMINER**        **Jack S. J. Chen**  
**ART UNIT:**     **2813**  
**FAX NO:**        **571-273-8300**

**FROM:**        Daryl K. Neff  
                 4 Eugene Circle  
                 Lincoln Park, NJ 07035  
                 Phone 973-316-2612

**FIS920030091US1**

**RECEIVED**  
**CENTRAL FAX CENTER**

AUG 20 2005

<b>AMENDMENT TRANSMITTAL LETTER</b>			Docket No. <b>FIS920030081US1</b>	
Application No. <b>10/604,146</b>	Filing Date <b>06/27/03</b>	Examiner <b>Jack S. J. Chen</b>	Art Unit <b>2813</b>	

Applicant(s): **Joel P. DeSouza et al.**

Invention: **SIMOX METHOD OF MAKING A BURIED OXIDE LAYER USING BASE IMPLANT AND ROOM TEMPERATURE IMPLANT**

**TO THE COMMISSIONER FOR PATENTS**

Transmitted herewith is an amendment in the above-identified application.  
 The fee has been calculated and is transmitted as shown below.

CLAIMS AS AMENDED				
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate
<b>Total Claims</b>	<b>5</b>	<b>20</b>	<b>0</b>	
<b>Independent Claims</b>	<b>1</b>	<b>- 3</b>	<b>0</b>	
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>				
Other fee (please specify):				
<b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:</b>				

☒ Large Entity ☐ Small Entity

☒ No additional fee is required for this amendment.

☐ Please charge Deposit Account No. \_\_\_\_\_ in the amount of \$ \_\_\_\_\_.  
 A duplicate copy of this sheet is enclosed.

☐ A check in the amount of \$ \_\_\_\_\_ to cover the filing fee is enclosed.

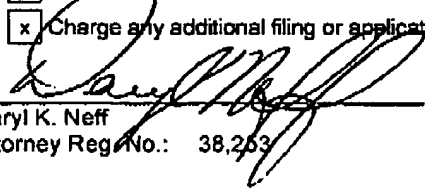
☐ Payment by credit card. Form PTO-2038 is attached.

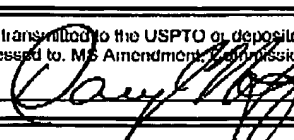
☒ The Director is hereby authorized to charge and credit Deposit Account No. **09-0458**  
 as described below. A duplicate copy of this sheet is enclosed.

☒ Credit any overpayment.

☒ Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.

Dated: August 20, 2005

  
 Daryl K. Neff  
 Attorney Reg. No.: 38,263

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: M/S Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below. Dated: August 20, 2005		Signature:  (Daryl K. Neff)
---	--	---

**RECEIVED  
CENTRAL FAX CENTER**

**AUG 20 2005**

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: MS Amendment, Commissioner for Patents, Alexandria, VA 22313-1450 on this date: August 20, 2005

Name of Depositor **Daryl K. Neff**

Signature 

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:  
**Joel P. DeSouza et al.**

Date: **August 20, 2005**

Serial Number: **10/604,146**

Examiner: **Jack S. J. Chen**

Filed: **June 27, 2003**

Group Art Unit: **2813**

Title: **SIMOX METHOD OF MAKING A  
BURIED OXIDE LAYER USING BASE  
IMPLANT AND ROOM TEMPERATURE  
IMPLANT**

H. Daniel Schnurmann  
IBM Corporation  
Dept. 18G, B/321, Zip 482  
2070 Route 52  
Hopewell Junction, NY 12533

**RESPONSE TO OFFICE COMMUNICATION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Communication dated July 21, 2005, Applicants submit the following amendments and remarks for the Examiner's consideration.

**FIS920030091US1**

**-1-**